

<b>Notice of References Cited</b>	Application/Control No. 10/590,969	Applicant(s)/Patent Under Reexamination ICHIKI, TAKANORI	
	Examiner Xiuyu Tai	Art Unit 1759	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Ichiki et al, "An atmospheric pressure micro plasma jet source for the optical emission spectroscopic analysis of liquid sample", Plasma Source Sci. Technol., 12(2003) S16-S 20
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	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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